

Notice of References Cited		Application/Control No. 10/577,069	Applicant(s)/Patent Under Reexamination HATA ET AL.	
		Examiner JULIA SLUTSKER	Art Unit 2891	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-4,040,849 A	08-1977	Greskovich et al.	423/348
*	B US-6,562,648 B1	05-2003	Wong et al.	438/46
*	C US-7,547,925 B2	06-2009	Wong et al.	257/103
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N					
O					
P					
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Panchula and Ying, "Nanocrystalline Aluminum Nitride: II, sintering and Properties," J.Am.Ceram.Soc., 86, 2003, pp.1121-1127.
V	
W	
X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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